

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/562,400 Confirmation No. : 8481  
First Named Inventor : Hiroshi Kannan  
Filed : April 25, 2006  
TC/A.U. : 1792  
Examiner : Mahmoud Dahimene  
Docket No. : 010986.57272US  
Customer No. : 23911  
Title : PLASMA GENERATION METHOD, CLEANING  
METHOD, AND SUBSTRATE PROCESSING METHOD

**REPLY TO OFFICE ACTION**

**Mail Stop AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

The following remarks are respectfully submitted in response to the non-final Office Action mailed April 2, 2009.

**Amendments to the Specification** are provided on page 2 of this paper.

**Amendments to the Claims** are reflected in the listing of claims, which begins on page 3 of this paper.

**Remarks** begin on page 22 of this paper.